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Day : Tuesday
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Inventor Name Search Result

Your Search was:

Last Name = KATO

First Name = SHIGEKAZU

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Serial#	Patent#	Status	Date Filed	Title	Inventor Name
07556449	5078851	115	07/24/1990	LOW-TEMPERATURE PLASMA PROCESSOR	KATO , SHIGEKAZU
07645420	Not Issued	166	01/24/1991	METHOD AND APPARATUS FOR DRY ETCHING	KATO , SHIGEKAZU
07724801	5320982	150	07/02/1991	WAFER COOLING METHOD AND APPARATUS	KATO , SHIGEKAZU
07751951	5314509	150	08/29/1991	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
07796672	Not Issued	166	11/25/1991	VACUUM PROCESSING SYSTEM	KATO , SHIGEKAZU
07941905	5448470	150	09/08/1992	MULTIPROCESSING APPARATUS	KATO , SHIGEKAZU
07971484	Not Issued	161	11/04/1992	METHOD AND APPARATUS FOR DRY ETCHING	KATO , SHIGEKAZU
08096256	5349762	150	07/26/1993	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
08131911	5445484	150	10/04/1993	VACUUM PROCESSING SYSTEM	KATO , SHIGEKAZU
08145181	5449467	150	11/03/1993	PROCESS FOR PURIFYING WATER	KATO , SHIGEKAZU
08302443	5457896	150	09/09/1994	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
08443039	5553396	150	05/17/1995	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU

08457595	Not Issued	161	06/01/1995	VACCUM PROCESSING SYSTEM	KATO , SHIGEKAZU
08460600	5673750	150	06/02/1995	VACUUM PROCESSING METHOD AND APPARATUS	KATO , SHIGEKAZU
08461512	Not Issued	161	06/05/1995	METHOD AND APPARATUS FOR DRY ETCHING	KATO , SHIGEKAZU
08461523	5663884	150	06/05/1995	MULTIPROCESSING APPARATUS	KATO , SHIGEKAZU
08487643	5562820	150	06/07/1995	PROCESS FOR PURIFYING WATER	KATO , SHIGEKAZU
08549791	Not Issued	166	01/26/1996	UTENSILS FOR TABLE USE AND COOKING USE	KATO , SHIGEKAZU
08593870	5661913	150	01/30/1996	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
08612465	5685684	150	03/07/1996	VACUUM PROCESSING SYSTEM	KATO , SHIGEKAZU
08882731	5784799	150	06/26/1997	VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS	KATO , SHIGEKAZU
08940019	5943950	150	09/29/1997	UTENSILS FOR TABLE USE AND COOKING USE	KATO , SHIGEKAZU
09061062	5950330	150	04/16/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
09177495	6012235	150	10/23/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
09231451	Not Issued	94	01/15/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU

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Inventor Name Search Result

Your Search was:

Last Name = KATO

First Name = SHIGEKAZU

Serial#	Patent#	Status	Date Filed	Title	Inventor Name
09389461	Not Issued	94	09/03/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
09390681	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
09390684	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
09461432	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
09461433	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	KATO , SHIGEKAZU
29099071	Not Issued	30	01/12/1999	VACUUM PROCESSING EQUIPMENT CONFIGURATION	KATO , SHIGEKAZU
29099072	Not Issued	30	01/12/1999	VACUUM PROCESSING SYSTEM CONFIGURATION	KATO , SHIGEKAZU

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Inventor Name Search Result

Your Search was:

Last Name = NISHIHATA

First Name = KOUJI

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Serial#	Patent#	Status	Date Filed	Title	Inventor Name
06493512	4527698	150	05/11/1983	METHOD OF AND APPARATUS FOR SUPPORTING ROPE OF CRANE HAVING	NISHIHATA , KOUJI
07556449	5078851	115	07/24/1990	LOW-TEMPERATURE PLASMA PROCESSOR	NISHIHATA , KOUJI
07645420	Not Issued	166	01/24/1991	METHOD AND APPARATUS FOR DRY ETCHING	NISHIHATA , KOUJI
07724801	5320982	150	07/02/1991	WAFER COOLING METHOD AND APPARATUS	NISHIHATA , KOUJI
07751951	5314509	150	08/29/1991	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
07796672	Not Issued	166	11/25/1991	VACUUM PROCESSING SYSTEM	NISHIHATA , KOUJI
07941905	5448470	150	09/08/1992	MULTIPROCESSING APPARATUS	NISHIHATA , KOUJI
07971484	Not Issued	161	11/04/1992	METHOD AND APPARATUS FOR DRY ETCHING	NISHIHATA , KOUJI
08096256	5349762	150	07/26/1993	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
08131911	5445484	150	10/04/1993	VACUUM PROCESSING SYSTEM	NISHIHATA , KOUJI
08302443	5457896	150	09/09/1994	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
08443039	5553396	150	05/17/1995	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI

08457595	Not Issued	161	06/01/1995	VACCUM PROCESSING SYSTEM	NISHIHATA , KOUJI
08460600	5673750	150	06/02/1995	VACUUM PROCESSING METHOD AND APPARATUS	NISHIHATA , KOUJI
08461512	Not Issued	161	06/05/1995	METHOD AND APPARATUS FOR DRY ETCHING	NISHIHATA , KOUJI
08461523	5663884	150	06/05/1995	MULTIPROCESSING APPARATUS	NISHIHATA , KOUJI
08593870	5661913	150	01/30/1996	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
08612465	5685684	150	03/07/1996	VACUUM PROCESSING SYSTEM	NISHIHATA , KOUJI
08882731	5784799	150	06/26/1997	VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS	NISHIHATA , KOUJI
08925190	Not Issued	93	09/08/1997	OPERATING METHOD OF VACUUM PROCESSING SYSTEM AND VACUUM PROCESSING	NISHIHATA , KOUJI
09061062	5950330	150	04/16/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
09177495	6012235	150	10/23/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
09231451	Not Issued	94	01/15/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
09389461	Not Issued	94	09/03/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
09390681	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI

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Inventor Name Search Result

Your Search was:

Last Name = NISHIHATA

First Name = KOUJI

Serial#	Patent#	Status	Date Filed	Title	Inventor Name
09390684	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
09452174	Not Issued	30	12/01/1999	ETCHING END POINT JUDGING METHOD, ETCHING END POINT JUDGING DEVICE,	NISHIHATA , KOUJI
09461432	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
09461433	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	NISHIHATA , KOUJI
29099071	Not Issued	30	01/12/1999	VACUUM PROCESSING EQUIPMENT CONFIGURATION	NISHIHATA , KOUJI
29099072	Not Issued	30	01/12/1999	VACUUM PROCESSING SYSTEM CONFIGURATION	NISHIHATA , KOUJI

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Inventor Name Search Result

Your Search was:

Last Name = TSUBONE

First Name = TSUNEHIKO

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Serial#	Patent#	Status	Date Filed	Title	Inventor Name
06674772	Not Issued	168	11/26/1984	VACUUM PROCESSING UNIT AND APPARATUS	TSUBONE , TSUNEHIKO
06675863	4565601	115	11/28/1984	METHOD AND APPARATUS FOR CONTROLLING SAMPLE TEMPERATURE	TSUBONE , TSUNEHIKO
06904202	4824309	115	09/08/1986	VACUUM PROCESSING UNIT AND APPARATUS	TSUBONE , TSUNEHIKO
07258468	4911812	150	10/17/1988	PLASMA TREATING METHOD AND APPARATUS THEREFOR	TSUBONE , TSUNEHIKO
07338038	5085750	115	04/14/1989	PLASMA TREATING METHOD AND APPARATUS THEREFOR	TSUBONE , TSUNEHIKO
07556449	5078851	115	07/24/1990	LOW-TEMPERATURE PLASMA PROCESSOR	TSUBONE , TSUNEHIKO
07645420	Not Issued	166	01/24/1991	METHOD AND APPARATUS FOR DRY ETCHING	TSUBONE , TSUNEHIKO
07724801	5320982	150	07/02/1991	WAFER COOLING METHOD AND APPARATUS	TSUBONE , TSUNEHIKO
07751951	5314509	150	08/29/1991	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHIKO
07796672	Not Issued	166	11/25/1991	VACUUM PROCESSING SYSTEM	TSUBONE , TSUNEHIKO
07941905	5448470	150	09/08/1992	MULTIPROCESSING APPARATUS	TSUBONE , TSUNEHIKO
07971484	Not Issued	161	11/04/1992	METHOD AND APPARATUS FOR DRY ETCHING	TSUBONE , TSUNEHIKO
08096256	5349762	150	07/26/1993	VACUUM PROCESSING APPARATUS AND OPERATING	TSUBONE , TSUNEHIKO

				METHOD THEREFOR	
08131911	5445484	150	10/04/1993	VACUUM PROCESSING SYSTEM	TSUBONE , TSUNEHIKO
08302443	5457896	150	09/09/1994	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHIKO
08307238	5792304	150	09/16/1994	METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM	TSUBONE , TSUNEHIKO
08443039	5553396	150	05/17/1995	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHIKO
08457595	Not Issued	161	06/01/1995	VACCUM PROCESSING SYSTEM	TSUBONE , TSUNEHIKO
08460600	5673750	150	06/02/1995	VACUUM PROCESSING METHOD AND APPARATUS	TSUBONE , TSUNEHIKO
08461512	Not Issued	161	06/05/1995	METHOD AND APPARATUS FOR DRY ETCHING	TSUBONE , TSUNEHIKO
08461523	5663884	150	06/05/1995	MULTIPROCESSING APPARATUS	TSUBONE , TSUNEHIKO
08593870	5661913	150	01/30/1996	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHIKO
08612465	5685684	150	03/07/1996	VACUUM PROCESSING SYSTEM	TSUBONE , TSUNEHIKO
08670180	Not Issued	94	06/20/1996	A SUBSTRATE HOLDING SYSTEM INCLUDING AN ELECTROSTATIC CHUCK	TSUBONE , TSUNEHIKO
08882731	5784799	150	06/26/1997	VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS	TSUBONE , TSUNEHIKO

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Last Name	First Name
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Inventor Name Search Result

Your Search was:

Last Name = TSUBONE

First Name = TSUNEHICO

Serial#	Patent#	Status	Date Filed	Title	Inventor Name
08979949	Not Issued	40	11/26/1997	PLASMA PROCESSING APPARATUS AND METHOD	TSUBONE , TSUNEHICO
09050417	5906684	150	03/31/1998	METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM	TSUBONE , TSUNEHICO
09061062	5950330	150	04/16/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09108835	Not Issued	41	07/02/1998	METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM	TSUBONE , TSUNEHICO
09109033	5985035	150	07/02/1998	METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM	TSUBONE , TSUNEHICO
09109178	Not Issued	120	07/02/1998	METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM	TSUBONE , TSUNEHICO
09177495	6012235	150	10/23/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09231451	Not Issued	94	01/15/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09389461	Not Issued	94	09/03/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO

09390681	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09390684	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09461432	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09461433	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	TSUBONE , TSUNEHICO
09478992	Not Issued	30	01/07/2000	METHOD OF HOLDING SUBSTRATE AND SUBSTRATE HOLDING SYSTEM	TSUBONE , TSUNEHICO
29099071	Not Issued	30	01/12/1999	VACUUM PROCESSING EQUIPMENT CONFIGURATION	TSUBONE , TSUNEHICO
29099072	Not Issued	30	01/12/1999	VACUUM PROCESSING SYSTEM CONFIGURATION	TSUBONE , TSUNEHICO

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Inventor Name Search Result

Your Search was:

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First Name = ATSUSHI

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Serial#	Patent#	Status	Date Filed	Title	Inventor Name
07556449	5078851	115	07/24/1990	LOW-TEMPERATURE PLASMA PROCESSOR	ITOU , ATSUSHI
07615554	5105173	115	11/19/1990	BAND-PASS FILTER USING MICROSTRIP LINES AND FILTER CHARACTERISTIC	ITOU , ATSUSHI
07645420	Not Issued	166	01/24/1991	METHOD AND APPARATUS FOR DRY ETCHING	ITOU , ATSUSHI
07724801	5320982	150	07/02/1991	WAFER COOLING METHOD AND APPARATUS	ITOU , ATSUSHI
07751951	5314509	150	08/29/1991	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
07796672	Not Issued	166	11/25/1991	VACUUM PROCESSING SYSTEM	ITOU , ATSUSHI
07941905	5448470	150	09/08/1992	MULTIPROCESSING APPARATUS	ITOU , ATSUSHI
07971484	Not Issued	161	11/04/1992	METHOD AND APPARATUS FOR DRY ETCHING	ITOU , ATSUSHI
08096256	5349762	150	07/26/1993	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
08131911	5445484	150	10/04/1993	VACUUM PROCESSING SYSTEM	ITOU , ATSUSHI
08302443	5457896	150	09/09/1994	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
08443039	5553396	150	05/17/1995	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI

08457595	Not Issued	161	06/01/1995	VACCUM PROCESSING SYSTEM	ITOU , ATSUSHI
08460600	5673750	150	06/02/1995	VACUUM PROCESSING METHOD AND APPARATUS	ITOU , ATSUSHI
08461512	Not Issued	161	06/05/1995	METHOD AND APPARATUS FOR DRY ETCHING	ITOU , ATSUSHI
08461523	5663884	150	06/05/1995	MULTIPROCESSING APPARATUS	ITOU , ATSUSHI
08593870	5661913	150	01/30/1996	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
08612465	5685684	150	03/07/1996	VACUUM PROCESSING SYSTEM	ITOU , ATSUSHI
08882731	5784799	150	06/26/1997	VACUUM PROCESSING APPARATUS FOR SUBSTATE WAFERS	ITOU , ATSUSHI
09061062	5950330	150	04/16/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
09158282	6028147	150	09/22/1998	BLOCK COPOLYMER, PROCESS FOR PRODUCING THE SAME AND RESIN COMPOSITION	ITOU , ATSUSHI
09177495	6012235	150	10/23/1998	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
09231451	Not Issued	94	01/15/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
09389461	Not Issued	94	09/03/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
09390681	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI

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Inventor Name Search Result

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Last Name = ITOU

First Name = ATSUSHI

Serial#	Patent#	Status	Date Filed	Title	Inventor Name
09390684	Not Issued	94	09/07/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
09461432	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
09461433	Not Issued	30	12/16/1999	VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR	ITOU , ATSUSHI
29099071	Not Issued	30	01/12/1999	VACUUM PROCESSING EQUIPMENT CONFIGURATION	ITOU , ATSUSHI
29099072	Not Issued	30	01/12/1999	VACUUM PROCESSING SYSTEM CONFIGURATION	ITOU , ATSUSHI

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